



Corres. and Mail
BOX AF

AP/2800

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2877**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Katsura OTAKI

Group Art Unit: 2877

Application No.: 09/780,414

Examiner: S.A. Turner

Filed: February 12, 2001

Docket No.: 108598

For: **POINT DIFFRACTION INTERFEROMETER FOR MEASURING PROFILE
IRREGULARITIES (AS AMENDED)**

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the June 11, 2003 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.

RECEIVED
SEP 16 2003
TECHNOLOGY CENTER 2800